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Atty. Dkt. No. 023228-0109

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steele et al.
Title: WAFER INSPECTION SYSTEM
Appl. No.: 10/771,628
Filing Date: 02/03/2004
Examiner:
Art Unit: 2812

<p>CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below.</p> <p><u>JORIE JOHNSON</u> (Printed Name)</p> <p><u>Jorie Johnson</u> (Signature)</p> <p><u>OCTOBER 22, 2004</u> (Date of Deposit)</p>

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.56**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith on Form PTO/SB/08 is a listing of documents known to Applicants in order to comply with Applicants' duty of disclosure pursuant to 37 CFR §1.56. A copy of each listed document, except as noted below, is being submitted to comply with the provisions of 37 CFR §1.97 and §1.98.

The USPTO has waived the requirement under 37 CFR 1.98(a)(2)(i) to submit copies of U.S. patents and U.S. patent application publications when citing and submitting an Information Disclosure Statements in a patent application filed after June 30, 2003 and in an international application that has entered the national stage under 37 USC §371 after June 30, 2003. Accordingly, copies of these types of documents are not being supplied in connection with this application. Reference is being made to OG Notice dated August 5, 2003, *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003.*

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application or that such document is considered material to patentability as defined in 37 CFR §1.56(b). Applicants do not waive any rights to take any action which would be appropriate to antedate or otherwise remove as a competent reference any document which is determined to be a *prima facie* art reference against the claims of the present application.

TIMING OF THE DISCLOSURE

The listed documents are being submitted in compliance with 37 CFR §1.97(b), before the mailing date of the first Office Action on the merits, and within three (3) months of the mailing date of the foreign search report.

RELEVANCE OF EACH DOCUMENT

Cite Nos. A61, and A64-A72 listed on the attached PTO/SB/08 were cited as being relevant during the prosecution of the corresponding International application. A copy of the International Search Report is attached setting forth the portion of each document considered relevant by the examiner. An English-language counterpart of the foreign-language document has not been provided, but an English-language Abstract accompanies such document. The absence of a translation or an English-language counterpart document does not relieve the PTO from its duty to consider any submitted document (37 CFR §1.98 and MPEP§609).

Applicants respectfully request that any listed document be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO/SB/08 be returned in accordance with MPEP §609.

STATEMENT

The undersigned hereby states in accordance with 37 CFR §1.97(e)(1) Cite Nos. A61, and A64-A72 listed on the attached PTO/SB/08 were first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to filing of this Statement.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application under 37 CFR §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 06-1450. Should no proper payment be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 06-1450.

Respectfully submitted,

Date Oct 22, 2004

By M. D. Rechtin

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Substitute for form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Date Submitted: October 22, 2004

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Sheet 1 of 3

Complete if Known

Application Number	10/771,628
Filing Date	February 3, 2004
First Named Inventor	M. Brandon Steele
Group Art Unit	2812
Examiner Name	
Attorney Docket Number	023228-0109

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
	A1	2002/0140564	A1	Danyluk et al.	10-03-2002	
	A2	2002/0186036	A1	Smith	12-12-2002	
	A3	2003/0129776	A1	Eom et al.	07-10-2003	
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Examiner
Signature

Date
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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**INFORMATION DISCLOSURE
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Date Submitted: October 22, 2004

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Sheet 2 of 3

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Application Number	10/771,628
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First Named Inventor	M. Brandon Steele
Group Art Unit	2812
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Attorney Docket Number	023228-0109

U.S. PATENT DOCUMENTS

U.S. Patent Document				
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A60	6,717,413		Danyluk et al.	04-06-2004

FOREIGN PATENT DOCUMENTS

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		Office ³	Number ⁴	Kind Code ⁵ (if known)				
	A61	WO	01/90730	A2	Sensorchem Int'l Corp.	11-29-2001	p. 17, ll. 15-30; figs. 10A-B	
	A62	DD	297509	A5	Kloedon R.	01-09-1992		A

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		First Named Inventor	M. Brandon Steele
		Group Art Unit	2812
		Examiner Name	
Sheet	3	of	3
		Attorney Docket Number	023228-0109

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶
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	A66	KORACH C S ET AL: "Measurement of perfluoropolyether lubricant thickness on a magnetic disk surface", Applied Physics Letters, American Institute of Physics, New York, NY, US; Vol. 79, No. 5, July 30, 2001, pp. 698-700, XP012029958, ISSN: 0003-6951 (p. 699, left column; fig. 2).	
	A67	YANG Y ET AL: "Kelvin probe study on the perfluoropolyether film on metals", Tribology Letters, 2001, Kluwer Academic/Plenum Publishers, USA, vol. 10, no. 4, pages 211-216, XP009035197, ISSN: 1023-8883 (page 211-page 212).	
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	A71	BAUMGARTNER H ET AL: "Micro Kelvin probe for local work-function measurements", Review of Scientific Instruments, May 1988, USA; Vol. 59, No. 5, pp. 802-805, XP002292442, ISSN: 0034-6748 (abstract; fig. 4, chapter "V. Results").	
	A72	DANYLUK S: "Non-vibrating contact potential imaging for semiconductor fabrication", Semicon West 2003, 'Online!', July 14, 2003, pp. 1-15, XP002292443, retrieved from the internet: ,URL:http://dom.semi.org/web/wFiles.nsf/Lookup/TIS18_QceptTechnologiesInc/\$file/TIS18%20QceptTechnologiesInc.Alternate.pdf. 'retrieved on August 13, 2004 (whole document).	

Examiner Signature		Date Considered	
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